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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/605,889	11/04/2003	Michael P. Belyansky	FIS920030286US1	2888
32074	7590 02/16/2005		EXAMINER	
INTERNATIONAL BUSINESS MACHINES CORPORATION DEPT. 18G BLDG. 300-482 2070 ROUTE 52 HOPEWELL JUNCTION, NY 12533			PHAM, LONG	
			ART UNIT	PAPER NUMBER
			2814	·
			DATE MAILED: 02/16/2005	

Please find below and/or attached an Office communication concerning this application or proceeding.

	·	Application No.	Applicant(s)			
Office Action Summary		10/605,889	BELYANSKY ET AL.			
		Examiner	Art Unit			
		Long Pham	2814			
	The MAILING DATE of this communical		ith the correspondence address			
Period fo	r Reply					
THE I - Exter after: - If the - If NO - Failui Any r	DRTENED STATUTORY PERIOD FOR MAILING DATE OF THIS COMMUNICA sions of time may be available under the provisions of 3 SIX (6) MONTHS from the mailing date of this communic period for reply specified above is less than thirty (30) do period for reply is specified above, the maximum statutor to reply within the set or extended period for reply will, eply received by the Office later than three months after the patent term adjustment. See 37 CFR 1.704(b).	TION. 7 CFR 1.136(a). In no event, however, may a reation. ays, a reply within the statutory minimum of thirming period will apply and will expire SIX (6) MON by statute, cause the application to become AB	reply be timely filed ty (30) days will be considered timely. ITHS from the mailing date of this communication. BANDONED (35 U.S.C. § 133).			
Status						
1) 🖂	Responsive to communication(s) filed of	on 22 November 2004.				
· <u> </u>						
•						
Dispositi	on of Claims					
5)⊠ 6)⊠ 7)□	Claim(s) <u>1-30</u> is/are pending in the app 4a) Of the above claim(s) <u>21-30</u> is/are version Claim(s) <u>8-20</u> is/are allowed. Claim(s) <u>1-7</u> is/are rejected. Claim(s) is/are objected to. Claim(s) are subject to restriction	vithdrawn from consideration.				
Applicati	on Papers					
9) 🔲 .	The specification is objected to by the E	xaminer.				
10)	The drawing(s) filed on is/are: a)	☐ accepted or b)☐ objected to	by the Examiner.			
	Applicant may not request that any objectio	n to the drawing(s) be held in abeya	nce. See 37 CFR 1.85(a).			
11)	Replacement drawing sheet(s) including the The oath or declaration is objected to by	•				
Priority u	ınder 35 U.S.C. § 119					
a)[Acknowledgment is made of a claim for All b) Some * c) None of: 1. Certified copies of the priority does 2. Certified copies of the priority does 3. Copies of the certified copies of the application from the International see the attached detailed Office action for	cuments have been received. cuments have been received in A the priority documents have been Bureau (PCT Rule 17.2(a)).	Application No received in this National Stage			
Attachment						
· <u></u>	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-		Summary (PTO-413) s)/Mail Date			
3) 🔲 Inform	nation Disclosure Statement(s) (PTO-1449 or PTO r No(s)/Mail Date		nformal Patent Application (PTO-152)			

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DETAILED ACTION

Rejections and/or objections necessitated by the amendments Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 1, 2, 3, 4, 5, 6, and 7 are rejected under 35 U.S.C. 103(a) as being unpatentable over the applicant's admitted prior art (AAPA) of this application in combination with Harms et al. (US 4,994,141), and Ajmeria et al. (US 2003/0010972).

With respect to claims 1 and 4, AAPA teaches a method of relaxing a stress present in a film contacting a base layer by reducing the stress of the film. See the Background of the Invention of this application.

However, AAPA fails to teach the reduction of stress is done by oxidizing the film by applying heat.

Harms et al. teach reducing stress of a film by oxidation by applying heat. See col. 3, lines 1-25.

It would have been obvious to one of <u>ordinary skill</u> in the art of making semiconductor devices to reduce the stress of the film as taught by Harms et al. in the method of AAPA because the reduction method of Harms et al. can be reproducible. See col. 3, lines 1-25.

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Further with respect to claims 1 and 4, Harms et al. teach that oxidation is done by applying heat but fail to teach that oxidation is done by using heat and atomic oxygen.

Ajmeria et al. teach oxidizing by applying heat and atomic oxygen to reduce the thermal budget of oxidation process. See [0014].

It would have been obvious to one of <u>ordinary skill</u> in the art of making semiconductor devices to use heat and atomic oxygen to produce oxidation in the process of AAPA and Harms et al. to achieve the above advantage.

With respect to claim 2, AAPA further teaches the stress is either tensile or compressive. See the Background of the Invention of this application.

With respect to claim 3, Ajmeria et al. fail to teach that the atomic oxygen is generated by high density plasma.

However, the generation of atomic oxygen by high density plasma is well-known.

Further with respect to claim 3, it is submitted that the temperature range for the generation of atomic oxygen is optimizable.

With respect to claims 5 and 7, AAPA further teaches selectively reducing the stress of the film and Harms et al. teaches reduction by oxidation.

It would have been obvious to one of <u>ordinary skill</u> in the art of making semiconductor devices to selectively oxidize the film to selectively reduce the stress of the film to obtain advantages as described in the Background of this specification.

With respect to claim 6, AAPA and Harms et al. fail to teach annealing the oxidized film.

However, the annealing of a film is well-known to one skilled in the art of making semiconductor devices.

Further, since AAPA in combination with Harms et al. teach the claimed oxidized film, additional heating of the film would not change the stress of the film.

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Response to Arguments

3. Applicant's arguments with respect to claims 1-7 have been considered but are most in view of the new ground(s) of rejection.

In response to the applicants' arguments in the paragraphs on pages 3 and 4 of the response dated 11/22/04, it is submitted that line 5 of [0007] of the Background of the Invention of this application teaches altering (reducing or increasing) stress of a layer contacting a base layer. Further, it is submitted that reducing stress means relaxing stress.

Allowable Subject Matter

4. Claims 8-20 are allowed.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Long Pham whose telephone number is 571-272-1714. The examiner can normally be reached on M-F, 7:30AM-3:00PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wael Fahmy can be reached on 571-272-1705. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Long Pham